

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Sung Chul Kang, et al.	)	
		)	Group Art Unit: 1752
Serial No.:	10/750,845	)	
		)	
Filed:	January 5, 2004	)	
		)	Examiner: Chu, John S. Y.
For:	PHOTORESIST COMPOSITION FOR	)	
	MULTI-MICRO NOZZLE HEAD COATER	)	

**AMENDMENT AND RESPONSE**

**VIA FACSIMILE TO: 1-571-273-8300**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This Amendment and Response is in response to the Office Action dated October 4, 2006. Please amend the application as follows: